

FORM PTO-1449 (MODIFIED) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT	ATTORNEY DOCKET NO.	SERIAL NO.
	SP01-131A	
	APPLICANT Po Ki Yuen et al.	
	FILING DATE	GROUP: 1744

REFERENCE DESIGNATION				U.S. PATENT DOCUMENTS			
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
<i>DMG</i>	AA	5,100,775	03-31-92	P.J. Smyczek et al.	435	6	
	AB	5,188,963	02-23-93	M.J. Stapleton	435	299	
	AC	5,346,672	09-13-94	M.J. Stapleton et al.	422	102	
	AD	5,451,500	09-19-95	M.J. Stapleton	435	6	
	AE	5,681,741	10-1997	Atwood et al.	435	287.2	
	AF	5,922,604	07-13-99	M.J. Stapleton et al.	436	46	
	AG	6,114,122	09-2000	Besemer et al.	435	6	
	AH	6,159,727	12-12-00	D. Bochkariov	435	287.2	
	AI	6,258,593	07-2001	Schembri et al.	435	287.2	
	AJ	6,287,768	09-2001	Chenchik et al.			
	AK	6,422,249	07-2002	Certa et al.	134	168R	
	AL	2002/0150933	10-2002	Ehricht et al.	435	6	
<i>DMG</i>	AM	2002/0061529	05-2002	Bridgham et al.	435	6	

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)		
<i>DMG</i>	AR	Deniz Armani et al., "Re-Configurable Fluid Circuits by PDMS Elastomer Micromachining", 12th International Conference on MEMS, MEMS 99, pp.222-227, Orland, FL, 1998
	AS	
	AT	
	AU	
	AV	
	AW	

EXAMINER:

Paul Riedel

DATE CONSIDERED:

3/5/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.